

Scanning Electron Microscopy

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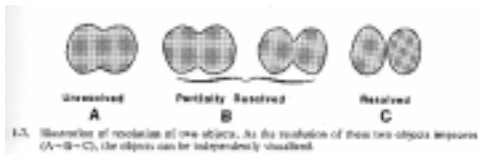
Considerations in Microscopy

- Magnification
- Resolution
 - Smallest separation of two points that are visible as distinct entities
 - Headlights
- High magnification without high resolution is "empty"

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Resolution



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Light Microscopy

- Resolving limit
 - Eye 0.1 mm
 - Light microscope 0.2 μm
 - SEM 3 nm
 - TEM 0.2 nm

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Abbe's Equation

- Resolution in the light microscope is limited by the wave nature of light

■ Where:

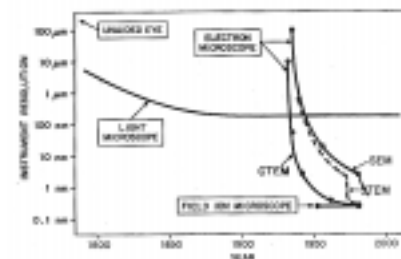
$$d = \frac{0.612\lambda}{n \sin \alpha}$$

- d is the resolution
- Smaller is better
- λ is the wavelength
- n is the index of refraction
- α is the aperture angle

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Evolution of Resolution



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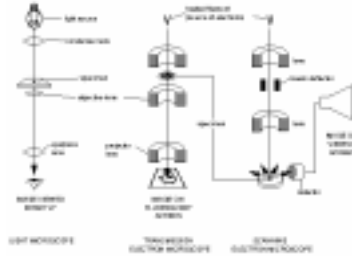
Light vs. e⁻

- As λ increases, d increases
- Best resolution is lowest λ
- $\lambda(\text{Blue}) \cong 400 \text{ nm}$
- $\lambda = h/mv$
- $\lambda(e^- \text{ 60 kV}) = 0.005 \text{ nm}$

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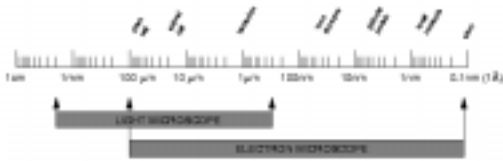
Light Microscope vs. EM



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Light Microscope vs. SEM

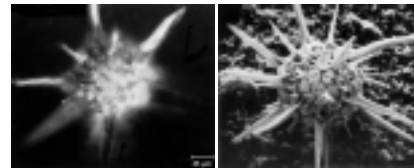


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SEM

- Magnification < 100,000 X
- Large Depth of Field



■ Radiolarian

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SEM

- | | |
|-------------------|-----------------|
| ■ Advantages | ■ Disadvantages |
| ■ Magnification | ■ Vacuum |
| ■ Resolving Power | ■ ex situ |
| ■ Depth of Field | ■ Conductive |
| | ■ Expensive |
| | ■ Maintenance |

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SEM History

- | | |
|--------------------|-----------------------------------|
| ■ 1878 Abbe | Light limit |
| ■ 1923 de Broglie | e ⁻ s are waves |
| ■ 1926 Busch | Can focus e ⁻ s with H |
| ■ 1932 Ruska | TEM |
| ■ 1938 Von Ardenne | built first SEM |
| ■ 1938 Siemens | First commercial TEM |
| ■ 1965 | First commercial SEM |

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SEM Applications

- Topography
 - Surface features
- Morphology
 - Shape, size, arrangement, etc.
- Composition
 - Elemental information
- Crystallographic
 - Arrangement of atoms in single crystals

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SEM Components

- Vacuum System
 - Mechanical Pump (Fore, or Rotary)
 - 500-1000 lpm
 - Achieve vacuum of 0.01 torr
 - Oil Diffusion Pump
 - 500-1000 lps
 - Achieve $10^{-(5-7)}$ torr
 - Can't be used above 0.01 torr

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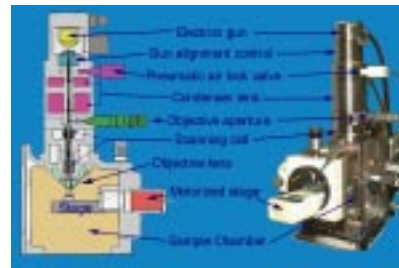
SEM Components

- Microscope Column
 - Electron Gun
 - Electromagnetic Lenses
 - Aperatures

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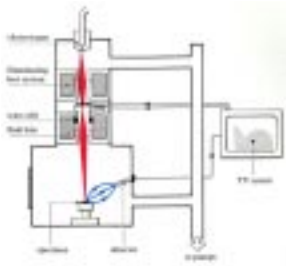
Beam Path Through Column



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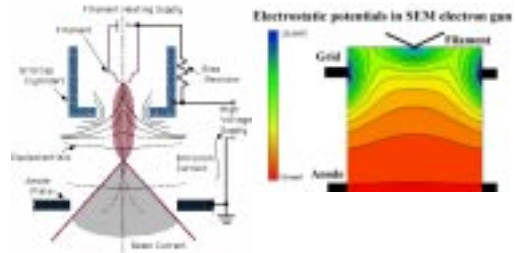
SEM Image Formation



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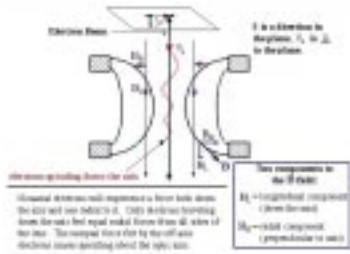
Electron Gun



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Cylindrical Magnetic Lenses



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Electron vs. Optical Lenses

- e⁻s don't actually touch lens
 - No definite interface
- e⁻s rotate in magnetic field
- e⁻s repel each other
- $f \propto H \propto I$
 - Focus and Magnification controlled electrically
 - No physical movements

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Electron vs. Optical Lenses

- e⁻ lenses can only be positive elements (converging)
- Can't correct e⁻ lens aberrations like you can with compound optical lenses
- e⁻ lenses always operate at small apertures

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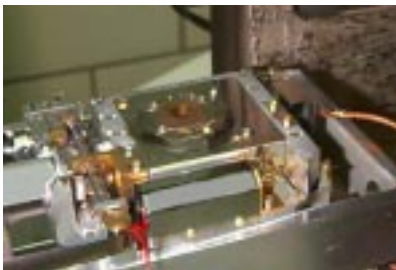
SEM Components

- Scan Coils
- Specimen Stage

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Sample Stage



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